Ultra Low-Profile Retroreflector[™] - ULPR[™]



The Ultra Low-Profile Retroreflector[™] (ULPR[™]) series is a cutting-edge ultralight compact retroreflector. This series represents the PLX brand by having a rugged stability, offered in a range of accuracy options and configurations.

The Ultra Low-Profile Retroreflector™ (ULPR™) series will fit where other retros won't. The ULPR™ is the ideal retroreflector series with a 36% weight reduction over the other retroreflector series. The round shape of the retroreflector is ideal for direct mounting on to bores, standard optical bench lenses and mirror holders. The newest member of the PLX retroreflector family pushes performance further with its compact and sleek patent pending mounting design. The Ultra Low-Profile Retroreflector™ is also extremely stable across varying temperatures, vibration levels, and shock conditions.



Coating Types

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- B IR Enhanced Aluminum
- C Unprotected Aluminum
- D UV Enhanced Aluminum
- E Protected Silver
- G Protected Gold
- H Unprotected gold
- I Protected Aluminum

Specifications			
Substrate	Pyrex		
Housing material	Aluminum 6061		
Surface Flatness	λ/10 – λ/20 @633nm		
Surface Quality	80-50 Scratch-Dig		
Beam Deviation	0.25 – 30.0 Arcsecond		

The ULPRTM series is available in standard sizes of 0.5 in (12.7mm) to 5.0 in (125mm). The units are available in accuracies to 0.25 arc seconds beam deviation and $\lambda/10$ wave reflected wavefront error. The ULPRTM is provided in a versatile housing, which is compatible with all major mounting systems. The ULPRTM is available with a broad range of standard metallic coatings which meet all applicable MIL-specs. Unprotected metallic coatings are especially suited to interferometric applications. Custom coatings are available upon request.

Note:

Beam Deviation is the maximum deviation from parallelism, expressed in seconds of arc, of any single return beam from any of the 6 subapertures of the retroreflector, when the retroreflector is fully-illuminated.

Exiting Wavefront is the resultant maximum peak-to-valley wavefront deformation from a fully-illuminated retroreflector, where lambda = 633nm. (See next page)

Beam deviation and exiting wavefront are interrelated, and it is only necessary to specify one.

Certain high accuracy models may be heavier than indicated here. Check with us for actual weight.

Important Notice

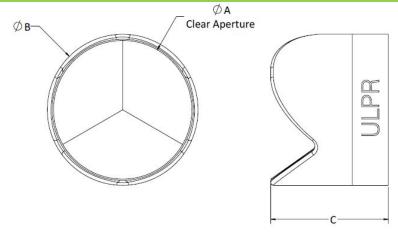
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Outline Drawings



Item	ØA (in/mm)	ØB (in/mm)	C (in/mm)
ULPR-05	0.50/12.70	0.58/14.61	0.50/12.57
ULPR-10	1.00/25.40	1.09/27.69	0.85/21.59
ULPR-15	1.48/37.54	1.57/39.82	1.22/30.99
ULPR-20	1.98/50.40	2.09/53.09	1.58/40.13
ULPR-25	2.37/60.14	2.48/62.99	1.85/46.99
ULPR-50	4.53/114.95	4.68/118.75	3.38/85.85

Specifications

ltem	Exiting Wavefront (p.v.633nm)	Weight (grams)
ULPR-05	0.30 - 0.90	3.26
ULPR-10	0.15 – 3.50	17.4
ULPR-15	0.10 - 5.25	46.6
ULPR-20	0.15 – 7.00	96-105
ULPR-25	0.25 – 9.00	159-168
ULPR-50	0.45 – 18.0	840-980

Coating Types

SUFFIX	WAVELENGTH RANGE (nm)	AOI 55° PER- SURFACE REFLECTANCE (AVG)
A	400 - 700	93%
В	600 - 1,600	89%
С	225 - 10,000	90%
D	225 - 700	89%
E	450 - 10,000	96%
G	650 - 16,000	97%
Н	650 - 20,000	97%
I	400 - 750	87%

Detailed coating curves are available in the following pages.

Custom Configurations

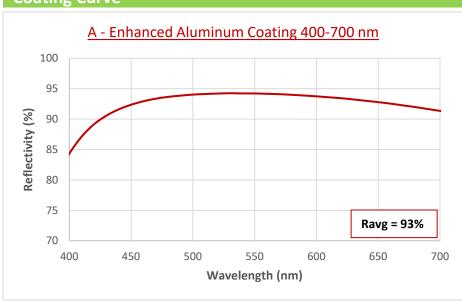
Custom configurations for specialized applications

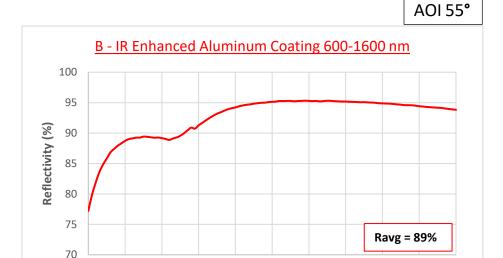
PLX engineers can create a custom product for your application. Potential variations include: smaller and larger apertures; modified mounts to meet your interface; super-critical accuracies; dielectric mirror coatings for high-powered lasers; and units able to withstand military and space environments.

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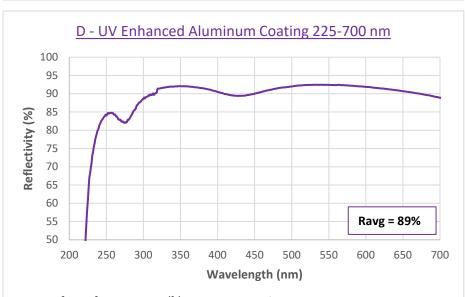












Not e: Coatings meet Ravg requirement, but coating curves are for reference as R(λ) may vary $\pm~2\%$

600

700

800

900

1000

1100

Wavelength (nm)

1200

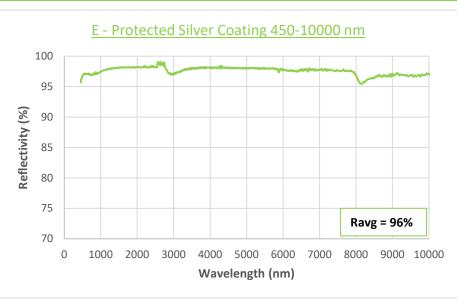
1300

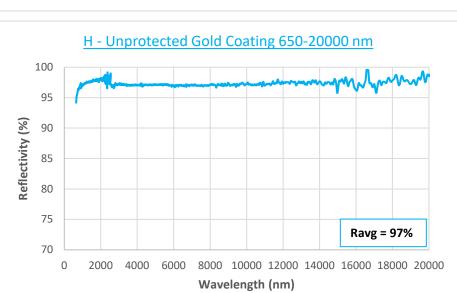
1400 1500

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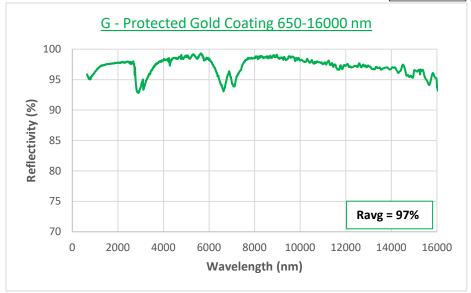


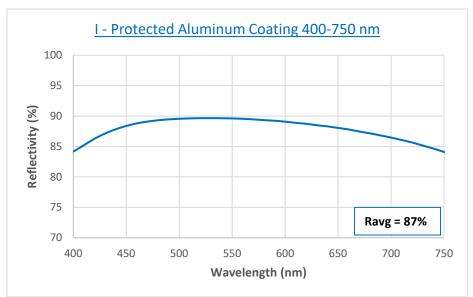
Coating Curve





AOI 55°





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